

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor:

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RESPONSE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

I HEREBY CERTIFY THAT THIS PAPER IS BEING SENT BY U.S. MAIL, FIRST CLASS, TO THE COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450,

Sir:

This is in response to the Office Action mailed on September 28, 2006. The election of inventions is contained in this Response.